



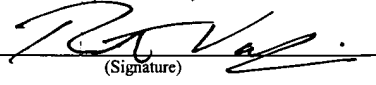
09-03-04

IFW

Atty. Dkt. No. 039153-0685
(AMD H1720)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Qi XIANG
Title: STRAINED SILICON MOSFETS
HAVING REDUCED DIFFUSION
OF N-TYPE DOPANTS
Appl. No.: 10/658,611
Filing Date: 9/9/2003
Examiner: USPTO_EXAMINER
Art Unit: 2812

CERTIFICATE OF EXPRESS MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service's "Express Mail Post Office To Addressee" service under 37 C.F.R. § 1.10 on the date indicated below and is addressed to: Mail Stop PGPUB, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
EV 420553772 US (Express Mail Label Number)	September 2, 2004 (Date of Deposit)
Ruthie Vallejo (Printed Name)	
 (Signature)	

REQUEST TO RESCIND PREVIOUS NONPUBLICATION REQUEST
35 U.S.C. 122(b)(2)(B)

Mail Stop PGPUB
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby rescinds the previous request that the above-identified application not be published under 35 U.S.C. 122(b).

Applicant furthermore hereby provides the notice to the Patent Office required by 35 U.S.C. 122(b)(2)(B)(iii) and 37 C.F.R. 1.213(c) that an application directed to the invention disclosed in the above-identified application was submitted in another country, or under a multilateral international agreement, that requires publication of applications eighteen months

after filing. This notice is being provided within forty-five days after the date of the filing of such foreign or international application.

Respectfully submitted,

Date 1 September 04

By Ronald Coslick

FOLEY & LARDNER LLP
Customer Number: 23392
Telephone: (310) 975-7964
Facsimile: (310) 557-8475

Ronald Coslick
Attorney for Applicant
Registration No. 36,489